

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent application of

:

Chul-Hwan Choi et al.

:

Box New Applications

Serial No. (new)

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Attorney Docket No. SEC.890

Filed January 18, 2002

:

SELF-CONTAINED SEMICONDUCTOR DEVICE MANUFACTURING
EQUIPMENT HAVING COMPACT ARRANGEMENT OF LOAD-LOCK AND
PROCESSING CHAMBERS

PRELIMINARY AMENDMENT

Honorable Commissioner For Patents
Washington, D.C. 20231

Sir:

Prior to the examination of the above-identified application, the following
amendments and remarks are submitted:

In the Specification¹

Kindly rewrite the paragraph at page 10, lines 9-11, to read as follows:

FIG. 14 is a top view of a still further embodiment of semiconductor device
manufacturing equipment having a robot that includes a branched wafer support
according to the present invention.

¹ A marked-up copy of any revised paragraphs of the original specification is attached as ATTACHMENT "A".

REMARKS

By this Preliminary Amendment, minor changes have been made to the specification.

Entry of this Preliminary Amendment is respectfully requested.

Respectfully submitted,

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ATTACHMENT “A”

Additions/Deletions to the Specification:

Page 10, lines 9-11:

FIG. 14 is a top [~~longitudinal sectional~~] view of a still further embodiment of semiconductor device manufacturing equipment having a robot that includes a branched wafer support according to the present invention.

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